



PATENT APPLICATION  
IN THE U.S. PATENT AND TRADEMARK OFFICE

January 30, 2002

Applicant(s): Bruce M. WARNES, et al.

For: CHEMICAL VAPOR DEPOSITION APPARATUS AND METHOD

Serial No.: 09/950 013 Group: 1762

Confirmation No.: 9221

Filed: September 10, 2001 Examiner: Unknown

Atty. Docket No.: MP-268B

Assistant Commissioner for Patents  
Washington, DC 20231

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INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the provisions of Rules 1.97(b)(3) and 1.98, enclosed herewith is Form PTO-1449 and the reference cited thereon. Accordingly, further comment at this point in time should not be necessary.

Further consideration is respectfully solicited.

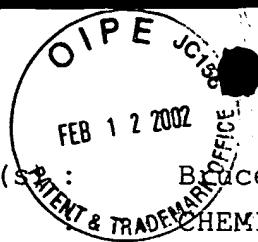
Respectfully submitted,

Edward J. Timmer

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Encl: Form PTO-1449  
One copy of each cited reference  
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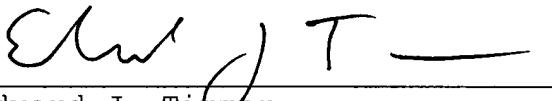
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FIRST CLASS MAILING CERTIFICATE

Sir:

I hereby certify that this correspondence is being deposited with the United States Postal Service under 37 CFR 1.8 as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington DC 20231, on January 30, 2002.

  
Edward J. Timmer

EJT/ad

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Correspondence: Information Disclosure Statement including enclosures listed thereon